

PATENT APPLICATION

NITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Yasuo FUKUDA, et al.

Appln. No.: 09/842,047

Confirmation No.: 6518

Filed: April 26, 2001

For:

Group Art Unit: 3729

Allowed: August 2, 2004

Docket No: Q64291

Examiner: Thiem D. PHAN

METHOD OF FORMING A PROJECTION ELECTRODE

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on July 23, 2004 between Examiner Thiem Phan and Kevin M. Barner:

REMARKS

An Examiner's Interview Summary Record (PTO-413) was attached with the Notice of Allowability mailed August 2, 2004.

The interview was initiated by the Examiner. Therefore, no further recordation by the Applicant is believed to be required.

During the interview, Applicants' representative authorized cancellation of the withdrawn claims 1-3 and 8-24 from the application.

It is respectfully submitted that the instant STATEMENT OF SUBSTANCE OF INTERVIEW complies with the requirements of 37 C.F.R. §§1.2 and 1.133 and MPEP §713.04. STATEMENT OF SUBSTANCE OF INTERVIEW

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It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,

SUGHRUE MION, PLLC

Telephone: (202) 293-7060

Facsimile: (202) 293-7860

WASHINGTON OFFICE 23373
CUSTOMER NUMBER

Date: August 31, 2004

Kevin M. Barner

Registration No. 46,075

Attorney Docket No.: Q64291